

Notice of References Cited

Application/Control No.

10/690,330

Applicant(s)/Patent Under

Reexamination

KIM ET AL.

Examiner

FEBEN HAILE

Art Unit

2616

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,274,695	09-2007	Kim et al.	370/389
	B	US-			
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	D	US-			
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	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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